

## APPLICATION DATA SHEET

## APPLICATION INFORMATION

Application Type:: REGULAR  
Subject Matter:: UTILITY  
CD-ROM or CD-R?:: NONE  
Title:: SILICON CARBIDE THERMOSTABLE  
POROUS STRUCTURAL MATERIAL  
AND PROCESS FOR PRODUCING THE  
SAME  
Attorney Docket Number:: 264179US0PCT

## INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR  
Primary Citizenship Country:: Japan  
Status:: FULL CAPACITY  
Given Name:: Eli  
Family Name:: ✓ TANI  
City of Residence:: Saga  
Country of Residence:: Japan  
Street of Mailing Address:: c/o Natl Inst. of Advanced Indust Science  
and Tech. Kyushu, 807-1, Shuku-machi  
Tosu-shi  
City of Mailing Address:: Saga  
Country of Mailing Address:: Japan  
Postal or Zip Code of Mailing Address:: 841-0052

## CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

## REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

## DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/09434	07/25/03

## FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-218247	Japan	07/26/02	YES

## ASSIGNMENT INFORMATION

Assignee Name::	National Institute of Advanced Indust Sci & Tech
Street of Mailing Address::	3-1, Kasumigaseki 1-chome, Chiyoda-ku
City of Mailing Address::	Tokyo
Country of Mailing Address::	Japan
Postal or Zip Code of Mailing Address::	100-8921